

**AMENDMENT UNDER 37 CFR 1.116 EXPEDITED
PROCEDURE – EXAMINING GROUP 1753**

PATENT

Attorney Docket No.: A7632/T49100
AMAT No.: 007632 USA/DSM/HDP/CVD/JPfeifer
TTC No.: 016301-049100US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

FARHAD K. MOGHADAM et al.

Application No.: 10/627,228

Filed: July 25, 2003

For: SEQUENTIAL GAS FLOW OXIDE
DEPOSITION TECHNIQUE

Customer No.: 57385

Confirmation No. 2446

Examiner: Rodney Glenn McDonald

Technology Center/Art Unit: 1753

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EXPEDITED PROCEDURE EXAMINING
GROUP 1753**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed September 17, 2007 on the above-referenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.